Se	arcn	Notes	

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/670,425	LIU ET AL.	LIU ET AL.	
Examiner	Art Unit	Art Unit	
Dennis L. Vautrot	2167	2167	

	SEARCHED		
Class	Subclass	Date	Examiner
707	100-105	3/27/2006	DV
709	200s	3/27/2006	dv
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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SEARCH (INCLUDING SEA	NOT RCH	ES STRATEGY))
		DATE	EXMR
East		3/27/2006	DV
			